

IN THE CLAIMS:

attachment to PTOL - 413
(do NOT detach)
Proposal - 6/12/06

1. (Currently Amended) A method for processing a specimen using a plasma,
comprising:

generating a plasma in a processing chamber in which the specimen is
disposed; and

5 processing the specimen with the plasma generated in the processing
chamber, wherein

the processing of the specimen comprises:

an irradiation operation for projecting and scanning a light beam into the
processing chamber through an observation window of the processing chamber;

10 a detection operation for detecting a light of the projected light beam which is
REFLECTED LIGHT SIGNAL CORRESPONDING TO A REFLECTED
A REFLECTED
reflected from an inside wall of the processing chamber, the light being detected by
WALL - REFLECTED
separating a light component from light emanated from the plasma and light reflected
from the inside wall by use of a spectroscope; and

15 a signal processing operation for obtaining information on a state of
contamination of the inside wall of the processing chamber, by processing THE WALL-REFLECTED LIGHT
AN ELECTRONIC
obtained at the detection operation by referring to a database storing predetermined
relationships between a CANDIDATE OBTAINABLE
signal signals obtained from said detection of light from said
inside wall and a state states of contamination of said inside wall.

TO DERIVE A STATE OF CONTAMINATION
CORRESPONDING TO THE WALL-REFLECTED LIGHT
SIGNAL, FROM THE ELECTRONIC DATABASE.

2. (Previously Presented) A method for processing a specimen using a
plasma according to Claim 1, comprising